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| Substitute For (Modified) | Substitute Form PTO-1449 (Modified) U.S. Department of Commerce Patent and Trademark Office | | Attorney's Docket No. 12732-044001 | | Application No. New Application | | | |
| Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | | | Applicant Hajime KIMURA | | | | | |
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| Other Documents (include Author, Title, Date, and Place of Publication) | | | | |
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| 1X2 | AQ | Yamaguchi, M. et al., "Two-Dimensional Contact-Type Image Sensor Using Amorphous Silicon Photo-Transistor", Japanese Journal of Applied Physics, vol. 32, No. 1B, Jan. 1993, pp. 458-461. | | |
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